

PATENT

**RESPONSE UNDER 37 C.F.R. 1.116 - EXPEDITED
PROCEDURE - EXAMINING GROUP 2814**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/762,789 Confirmation No. 6124
Applicant(s): Douglas G. Anderson
Filed: January 22, 2004
Art Unit: 2814
Examiner: Abdul Kalam
Title: WAFER, INTERMEDIATE WAFER ASSEMBLY AND ASSOCIATED
METHOD FOR FABRICATING A SILICON ON INSULATOR WAFER
HAVING AN IMPROVED EDGE PROFILE

Docket No.: 039035/267930 July 20, 2007
Customer No.: 00826

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Commissioner for Patents
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Alexandria, VA 22313-1450

REPLY TO FINAL OFFICIAL ACTION

Sir: OK TO ENTER: /AK/

In response to the Final Official Action dated March 20, 2007, please reconsider the above-identified patent application in view of the following:

Remarks begin on page 2 of this paper.